

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 10559-839001/Intel P16714	Application No. New Application 10/64862
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) IDS filed 8/25/2003		Applicant Manish Chandhok		10/13/04	
		Filing Date Unknown		Group Art Unit 2877	

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
ED	AA	6,481,003 B1	11/12/2002	Maeda			
RS	AB	6,567,155 B1	5/20/2003	Chandhok et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document	
ED	AQ	John E. Bjorkholm, "EUV Lithography—The Successor to Optical Lithography?", Intel Technology Journal Q3'98 (John.Bjorkholm@intel.com)	
	AR		
	AS		
	AT		

Examiner Signature <i>Danile Johnson</i>	Date Considered 10/13/04
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	